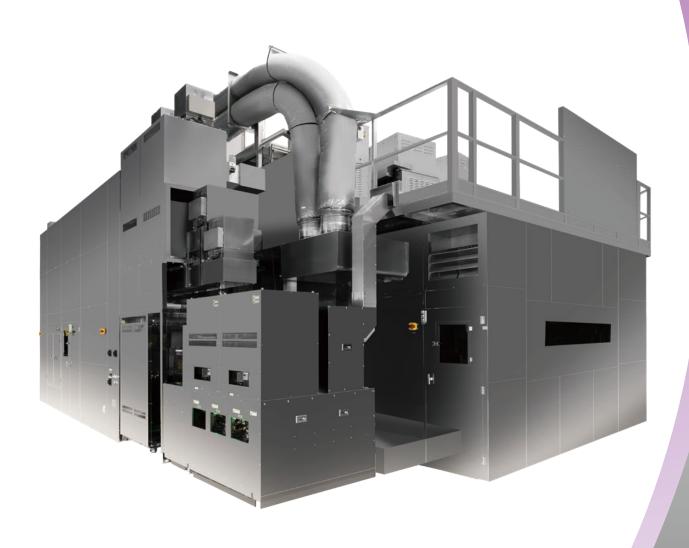


FPD Lithography System

FX-6AS

Gen 6 Plate FPD Lithography System with the Highest Level of Resolution



Gen 6 Plate FPD Lithography System with the Highest Level of Resolution

FPD Lithography System FX-6AS

The FX-6AS produces leading edge small-and-medium-sized high-definition panels from Gen 6 plates. The newly-developed projection lens enables the highest level of resolution of 1.0 µm using a phase shift mask, improved productivity and high overlay accuracy.

Key Features

• Multi-lens System

The FX-6AS features the multi-lens system consisting of multiple projection lenses. This design enables a wide exposure field and excellent resolution.

• High Resolution

Nikon has developed a new projection lens with a high NA that has further advanced the evolution of the previous model. The FX-6AS employs an i-line light source which has a track record in high volume production, and an innovative focus correction system that was developed for the FX-68SH/68S. These enable the high volume production of panels with a high resolution of 1.0 µm (L/S) using a phase shift mask, while ensuring high CD uniformity over the entire surface of Gen 6 plates.

• High Overlay Accuracy

High overlay accuracy is realized by using a new projection lens with reduced aberration in combination with highly accurate measurement and position control performance of the previous model.

• High Throughput

The FX-6AS achieves a high resolution of 1.0 μ m*¹ with the same exposure field as the previous model. It also provides a high throughput of 85 plates per hour due to increased illuminance resulting from optimization of the illumination system, while enabling 4-scan on a Gen 6 plate.

• Stable Exposure Performance

The FX-6AS employs a variety of calibration functions from the previous model, providing stable exposure performance during operation.

Performance	
Resolution (L/S)	1.0 μm* ¹ (i-line)
Projection magnification	1:1
Overlay	≦ ±0.23 μm
Plate size	1,500 mm × 1,850 mm
Takt time	42 s/plate Conditions: 1,500 mm × 1,850 mm, 4 scans, i-line, 30 mJ/cm ²

*1 When using a phase shift mask





WARNING

TO ENSURE CORRECT USAGE, READ THE CORRESPONDING MANUALS CAREFULLY BEFORE USING YOUR EQUIPMENT.

All of the products in this brochure are under export restriction. The export of these products is controlled by Japanese Foreign Exchange and Foreign Trade and International export control regime. They shall not be exported without authorization from the appropriate government authorities.

Performance and equipment are subject to change without any notice or obligation on the part of the

https://www.nikon.com/business/fpd/

manufacturer.

Products and brand names are trademarks or registered trademarks of their respective companies. April 2024

©2024 NIKON CORPORATION

Nikon Corporation Precision Equipment Group Marketing Department

Shinagawa Intercity Tower C, 2-15-3, Konan, Minato-ku, Tokyo 108-6290, Japan Tel: +81-3-6433-3639

Nikon Precision Korea Ltd.

2, Singal-ro 124beon-gil, Giheung-gu, Yongin-si, Gyeonggi-do, 16968 Korea **Tel**: +82-31-288-5601

Nikon Precision Taiwan Ltd.

3F.-1, NO.28, Taiyuan Street, Zhubei City, Hsinchu County 302, Taiwan, R.O.C. **Tel**: +886-3-552-5888

Nikon Precision (Shanghai) Co., Ltd.

11-12F, Tower 5, Crystal Plaza No. 36, Ping Jia Qiao Road, Pudong New District, Shanghai 200126, China **Tel**: +86-21-5899-0266